

Title (en)
APPARATUS FOR GENERATING F₂ GAS AND METHOD FOR GENERATING F₂ GAS, AND F₂ GAS

Title (de)
VORRICHTUNG ZUR ERZEUGUNG VON F₂-GAS UND VERFAHREN ZUR ERZEUGUNG VON F₂-GAS SOWIE F₂-GAS

Title (fr)
APPAREIL ET PROCEDE DE PRODUCTION D'UN GAZ F₂ ET GAZ F₂ AINSI OBTENU

Publication
EP 1457586 A4 20050713 (EN)

Application
EP 02783802 A 20021209

Priority
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Abstract (en)
[origin: EP1457586A1] An F₂ gas generating apparatus for generating a high purity F₂ gas by subjecting an electrolytic bath made of KF.2HF to electrolysis is characterized by comprising a preparing system for preparing KF.2HF from KF or KF.HF, an HF supplying system for supplying HF into the electrolytic bath and the preparing system, and an F₂ gas generating system for generating the F₂ gas by subjecting KF.2HF prepared by the preparing system to electrolysis. <IMAGE>

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C25B 1/24; **C25B 15/02**

IPC 8 full level
C25B 1/24 (2006.01); **C25B 15/00** (2006.01)

CPC (source: EP KR US)
C25B 1/245 (2013.01 - EP KR US); **C25B 15/00** (2013.01 - EP US); **C25B 15/021** (2021.01 - KR); **C25B 15/085** (2021.01 - KR)

Citation (search report)
• No further relevant documents disclosed
• See references of WO 03052167A1

Cited by
EP2476783A4

Designated contracting state (EPC)
DE FR GB

DOCDB simple family (publication)
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